



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE  
Group Art Unit 2624

*EPW*

In re

Patent Application of

Patrick James Noffke, et al.

Application No. 10/790,451

Confirmation No.: 9929

Filed: February 17, 2004

Examiner: Park, Edward

“SYSTEM AND METHOD FOR  
MEASURING COLOR ON A PRINTING  
PRESS”

INFORMATION REGARDING RELATED APPLICATION

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicants wish to direct the Examiner's attention to U.S. Application Serial No. 10/424,230, which is a parent application of the present case. This case is assigned to Art Unit 2624 and is being examined by Anand P. Bhatnagar. The subject matter of the parent application may be related to the subject matter of the present CIP Application.

Respectfully submitted,

Thomas J. Otterlee  
Reg. No. 48,652

File No. 077077-9159-01  
Michael Best & Friedrich LLP  
100 East Wisconsin Avenue  
Suite 3300  
Milwaukee, Wisconsin 53202-4108  
262-956-6523

I, Bridget Laack, hereby certify that this correspondence is being deposited with the US Postal Service as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date of my signature.

Signature Bridget Laack

Date of Signature 8/24/2007